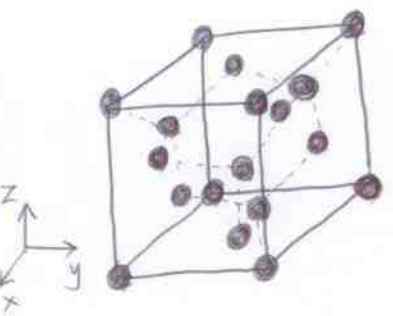


# Homework \*5. Solution

1. Si structure = FCC +  $\frac{1}{2}$  tetrahedral site ( $\frac{2}{8}$  874  $\frac{2}{8}$  474)  
(inversely occupied)



- (000, 100, 010, 001)
- 110, 101, 011, 111
- $\frac{1}{2}\frac{1}{2}0, 0\frac{1}{2}\frac{1}{2}, \frac{1}{2}0\frac{1}{2}, \frac{1}{2}\frac{1}{2}1$
- $1\frac{1}{2}\frac{1}{2}, \frac{1}{2}1\frac{1}{2}, \frac{1}{4}\frac{1}{4}\frac{1}{4}, \frac{3}{4}\frac{3}{4}\frac{1}{4}$
- $\frac{3}{4}\frac{1}{4}\frac{3}{4}, \frac{1}{4}\frac{3}{4}\frac{3}{4}$

Textbook

\*  $a_{Si} = 5.431 \text{ \AA}$

cell 당 atom 수 = 8

$\therefore$  density (atoms/cm<sup>3</sup>)

$$= 8 \times \frac{1}{(5.431 \times 10^{-10})^3}$$

$$= \underline{4.994 \times 10^{22} / \text{cm}^3}$$

(6.4. & 8.2 참조할것)

2.  $dN^* = N(E) dE$

$N(E) = 2Z(E) \cdot F(E)$

$Z(E) = \frac{V}{4\pi^2} \left(\frac{2m}{\hbar^2}\right)^{3/2} E^{1/2}$

$F(E) = \frac{1}{\exp\left(\frac{E-E_F}{k_B T}\right) + 1} \approx \exp\left[-\left(\frac{E-E_F}{k_B T}\right)\right]$

( $\because E-E_F \approx 0.5\text{eV}, k_B T = 10^{-2}\text{eV}$  at Room)

$$N^* = \frac{V}{2\pi^2} \cdot \left(\frac{2m}{\hbar^2}\right)^{3/2} \int_0^\infty E^{1/2} \exp\left[-\frac{E-E_F}{k_B T}\right] dE$$

$$= \frac{V}{2\pi^2} \cdot \left(\frac{2m}{\hbar^2}\right)^{3/2} \exp\left(\frac{E_F}{k_B T}\right) \int_0^\infty E^{1/2} \exp\left(-\left(\frac{E}{k_B T}\right)\right) dE$$

( $\because \int_0^\infty x^{1/2} e^{-nx} dx = \left(\frac{1}{2n}\right) \sqrt{\frac{x}{n}}$ )

$$N^* = \frac{V}{2\pi^2} \left(\frac{2m}{\hbar^2}\right)^{3/2} \exp\left(\frac{E_F}{k_B T}\right) \cdot \frac{k_B T}{2} (\pi k_B T)^{1/2}$$

$$= \frac{V}{4} \cdot \left(\frac{2mk_B T}{\pi \hbar^2}\right)^{3/2} \exp\left(\frac{E_F}{k_B T}\right)$$

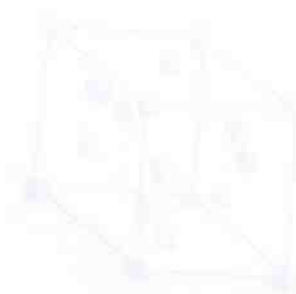
( $\because E_F = -\frac{E_g}{2}, m_e^*/m_0$  relation,  $N_e = N^*/V$ )

$$N_e = \frac{1}{4} \left( \frac{2m k_B}{\pi \hbar^2} \right)^{3/2} \left( \frac{m_e^*}{m_0} \right)^{3/2} T^{3/2} \exp \left( - \frac{E_g}{2k_B T} \right)$$

$$\frac{1}{4} \left( \frac{2m k_B}{\pi \hbar^2} \right)^{3/2} = 4.84 \times 10^{15} \text{ (cm}^{-3} \cdot \text{K}^{-3/2})$$

$$\therefore N_e = 4.84 \times 10^{15} \left( \frac{m_e^*}{m_0} \right)^{3/2} T^{3/2} \exp \left( - \frac{E_g}{2k_B T} \right)$$

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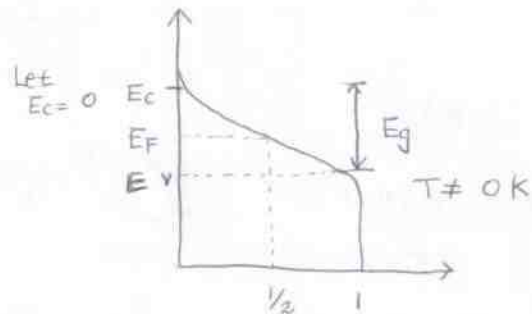


$$4. N_e = 4.84 \times 10^{15} \left( \frac{m_e^*}{m_0} \right)^{3/2} T^{3/2} \exp \left[ - \left( \frac{E_g}{2k_B T} \right) \right]$$

$$\frac{m_e^*}{m_0} = 1, \quad E_{g, 300K} = 1.12 \text{ eV}, \quad k_B = 8.616 \times 10^{-5} \text{ eV/K}$$

$$\therefore N_e = 4.84 \times 10^{15} (300)^{3/2} \cdot \exp \left( - \frac{1.12}{2 \times 8.616 \times 10^{-5} \times 300} \right)$$

$$= \underline{9.81 \times 10^9 / \text{cm}^3}$$



$$\text{Let } E_c = 0 \quad E_v = -E_g.$$

$$F(E) = \frac{1}{\exp\left(\frac{E-E_F}{k_B T}\right) + 1}$$

$$F(E_v) + F(E_c) = 1 = \frac{1}{\exp\left(\frac{E_v - E_F}{k_B T}\right) + 1} + \frac{1}{\exp\left(\frac{E_c - E_F}{k_B T}\right) + 1}$$

$$= \frac{1}{\exp\left(\frac{-E_g - E_F}{k_B T}\right) + 1} + \frac{1}{\exp\left(\frac{-E_F}{k_B T}\right) + 1}$$

$$\exp\left(\frac{-E_g - E_F}{k_B T}\right) + 1 = 1 + \frac{\exp\left(-\frac{E_g + E_F}{k_B T}\right) + 1}{\exp\left(-\frac{E_F}{k_B T}\right) + 1}$$

$$\exp\left(\frac{-E_g - 2E_F}{k_B T}\right) + \cancel{\exp\left(\frac{-E_g - E_F}{k_B T}\right)} = \cancel{\exp\left(-\frac{E_g + E_F}{k_B T}\right)} + 1$$

$$E_g + 2E_F = 0$$

$$\therefore E_F = -\frac{1}{2} E_g$$

$$6. N_e = 4.84 \times 10^{15} \left( \frac{m_e^*}{m_0} \right)^{3/2} T^{3/2} \exp\left(-\frac{E_g}{2k_B T}\right)$$

$$N_e = 10^{22} / \text{cm}^3, \quad E_g = 1 \text{ eV}, \quad k_B = 8.616 \times 10^{-5} \text{ eV/K}$$

$$\frac{m_e^*}{m_0} = 1$$

by using calculator ;  $T = 19735.13 \text{ K}$

7. Eq. (8.14)

$$n = 4.84 \times 10^{15} \left( \frac{m^*}{m_0} \right)^{3/2} T^{3/2} e^{(\mu_e + \mu_h)} \exp\left(-\frac{E_g}{2k_B T}\right)$$

$$= A T^{3/2} \exp\left(-\frac{E_g}{2k_B T}\right)$$

$$\left( \begin{array}{l} n=1, \quad 1/T = 0.8 \times 10^{-2} \\ n=10, \quad 1/T = 0.9 \times 10^{-2} \end{array} \right. \text{ 대입 .}$$

$$1 = A \left( \frac{1}{0.8 \times 10^{-2}} \right)^{3/2} \cdot \exp\left(-\frac{E_g}{2k_B} \cdot 0.8 \times 10^{-2}\right) \dots \textcircled{1}$$

$$10 = A \left( \frac{1}{0.9 \times 10^{-2}} \right)^{3/2} \cdot \exp\left(-\frac{E_g}{2k_B} \cdot 0.009\right) \dots \textcircled{2}$$

$$\frac{\textcircled{1}}{\textcircled{2}} \left( \frac{9}{8} \right)^{3/2} \exp\left(\frac{E_g}{2k_B} (0.009 - 0.008)\right) = \frac{1}{10}$$

$$\therefore E_g = \frac{2 \times 8.616 \times 10^{-5}}{0.009 - 0.008} \ln\left(\frac{1}{10} \cdot \left(\frac{8}{9}\right)^{3/2}\right) = 0.362 \text{ eV}$$

8.

$$\sigma = N_{de} \cdot \mu_e \cdot e$$

$$= 5 \times 10^{16} \text{ atoms/cm}^3 \times e \times 0.39 \text{ m}^2/\text{V}\cdot\text{s}$$

$$= 3.12 \times 10^{-3} \text{ electrons/cm}^3 \cdot \text{C} \cdot \text{m}^2/\text{V}\cdot\text{s}$$

$$= \underline{31.2 (\Omega \cdot \text{cm})^{-1}}$$

$$\frac{N^*}{V} = \frac{1}{4} \left( \frac{2m k_B T}{\pi \hbar^2} \right)^{3/2} \exp\left( -\frac{E_F}{k_B T} \right)$$

$$= 5 \times 10^{22} / m^3 \quad \left( \begin{array}{l} m_e = 9.11 \times 10^{-31} \text{ kg} \\ k_B = 1.381 \times 10^{-23} \text{ J/K} \end{array} \quad \begin{array}{l} T = 298 \text{ K} \\ \hbar = 1.054 \times 10^{-34} \text{ J}\cdot\text{s} \end{array} \right)$$

$$\therefore \underline{E_F = -0.1595 \text{ eV}}$$

9. (a) at 300K 대부분의 donor 전자가 excited 된다.  
(상온이상)

$$N_e = 10^{13} \text{ electrons/cm}^3$$

$$(b) N_e = 4.84 \times 10^{15} \left( \frac{m_{e^*}}{m_0} \right)^{3/2} T^{3/2} \exp\left( -\frac{E_g}{2k_B T} \right)$$

$$\frac{m_{e^*}}{m_0} = 1, T = 300 \text{ K}, k_B = 8.616 \times 10^{-5} \text{ eV/K}, E_g = 1 \text{ eV}$$

$$N_e = 9.9909 \times 10^{10} \text{ electrons/cm}^3$$

(c) extrinsic electron의 기여가 100 배정도 크다.

$$10. E = \frac{m^* e^4}{2(4\pi\epsilon_0 \cdot \hbar)^2 \cdot \epsilon^2} = \frac{0.8 \times 9.11 \times 10^{-31} \times (1.602 \times 10^{-19})^4}{2 \times (4\pi \times 8.854 \times 10^{-12} \times 6.982 \times 10^{-16})^2 \times 16^2}$$

$$= 0.0425 \text{ eV}$$

$$= 42.5 \text{ meV}$$

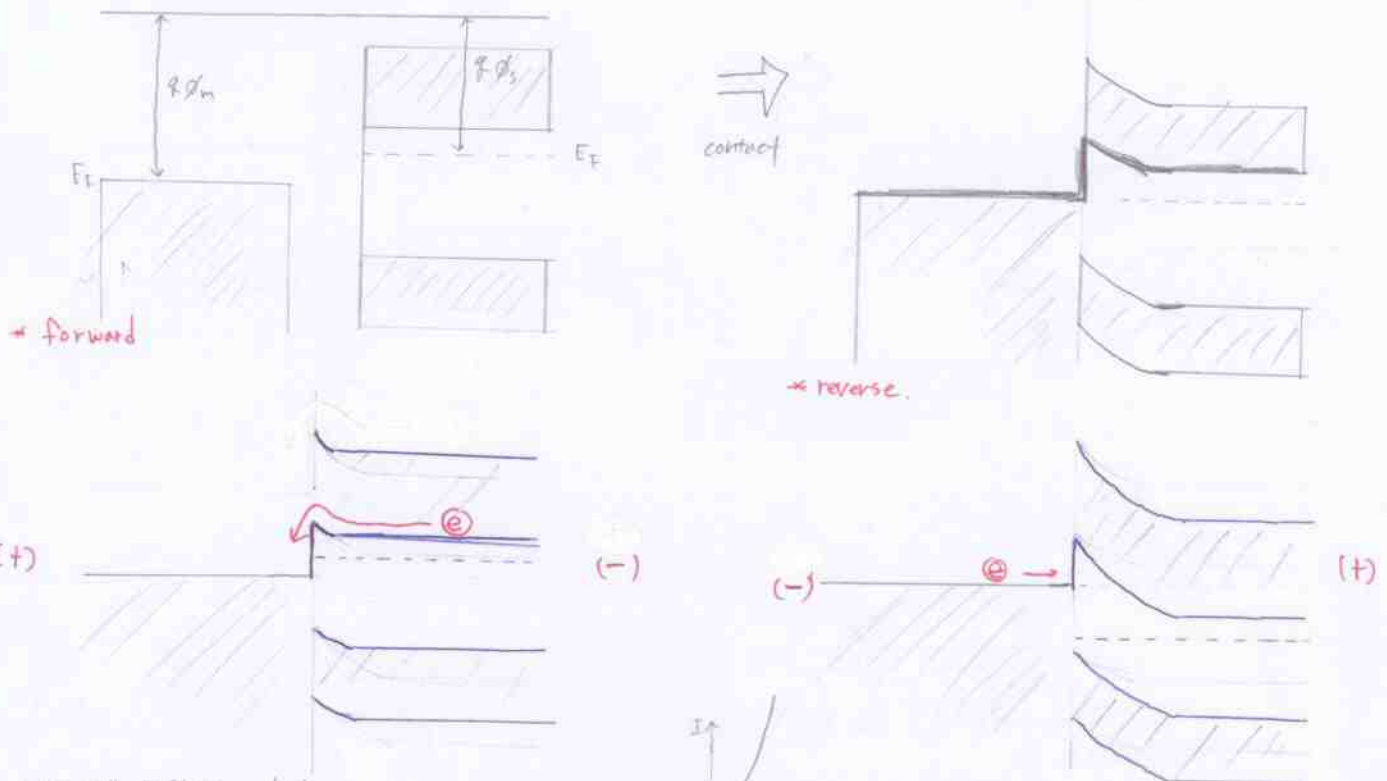
이는 n-type Si의 Ionization E와 비슷하다.

Si (Donor)	Sb	: 0.039 eV
	P	: 0.045 eV
	As	: 0.054 eV

\(\therefore\) 가정의 reasonable 함을 알 수 있다.

\* 3

(a) N-type,  $\phi_m > \phi_s$



·  $V$ 의 크기가 증가할수록 depletion width & potential barrier 감소

· 2차 diffusion current (semi-conductor  $\rightarrow$  metal) 없음.



- rectifying contact.

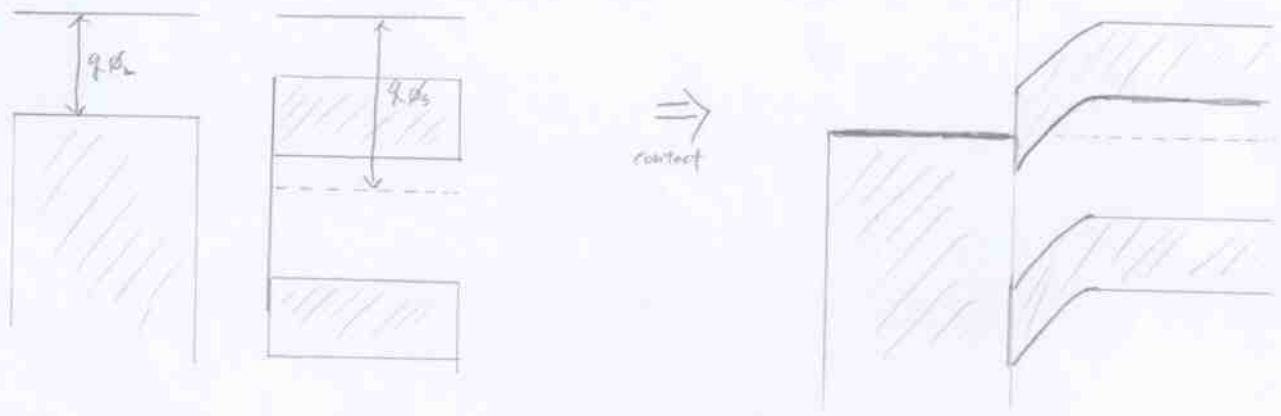
(reverse bias와 전압이 커지면 전류가 거의 0이 됨!)

·  $V$ 의 크기가 증가할수록 depletion width & potential barrier 증가.

· 2차 diffusion current 있음. (양방향)

· 양방향 diff current 한이 존재

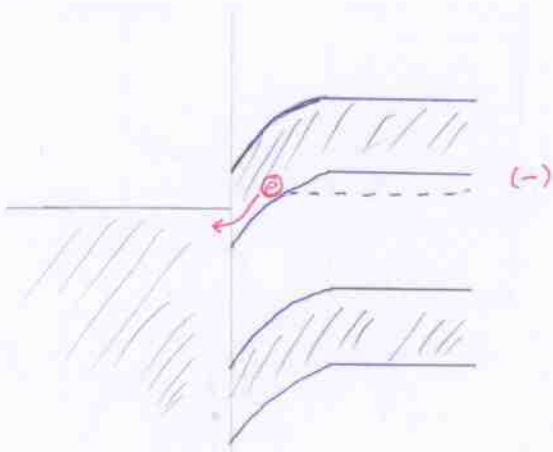
(b) N-type,  $\phi_m < \phi_s$



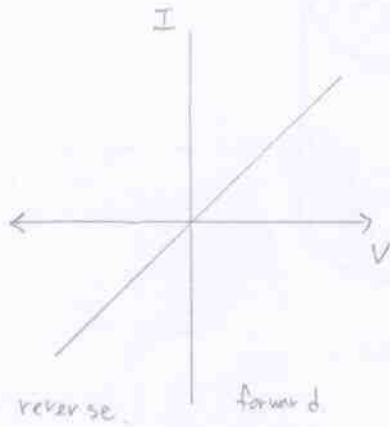
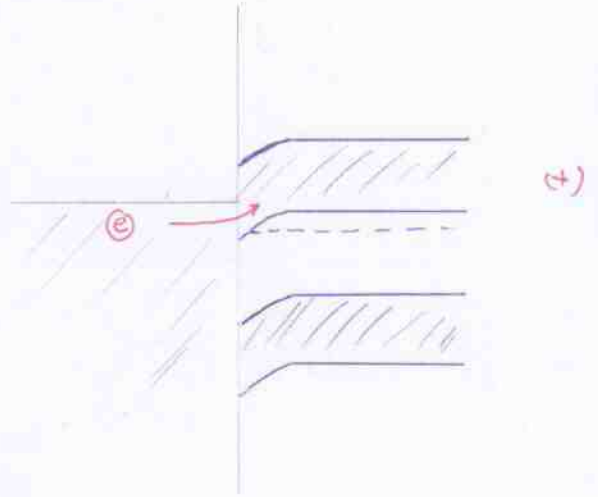
\* forward

\* reversed

(+)



(-)



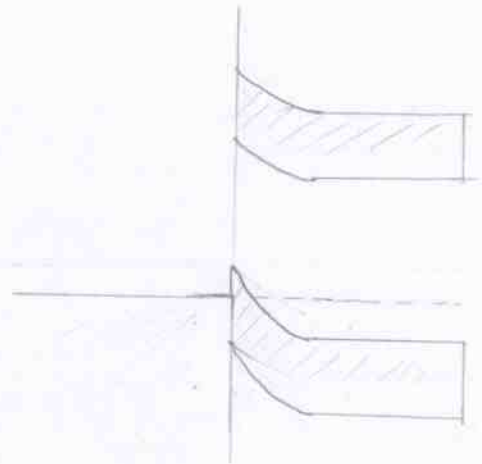
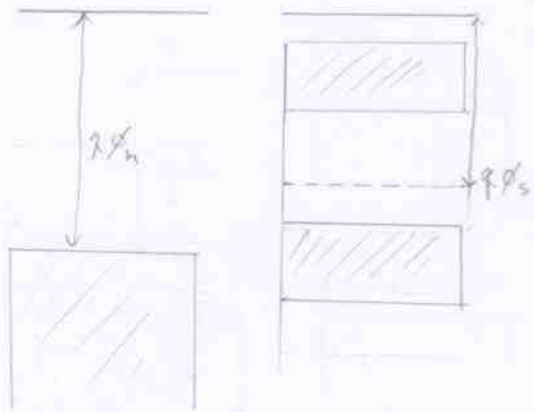
외부의 전계를 인가하면 전압이 증가함에 따라

linearly 전도도 증가 (ohm's law).

forward 및 reverse 모두 전하 캐리어가  
(전자가 major charge carrier)

∴ ohmic contact.

(c) P-type,  $q\phi_m > q\phi_s$



\*forward

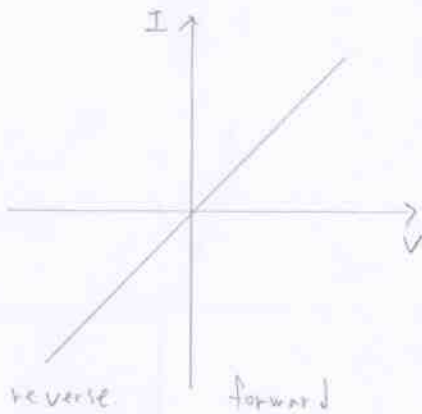
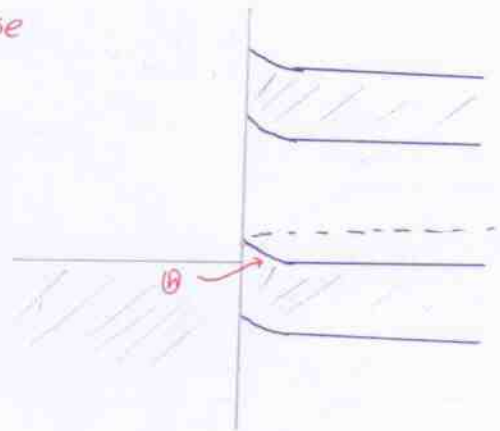
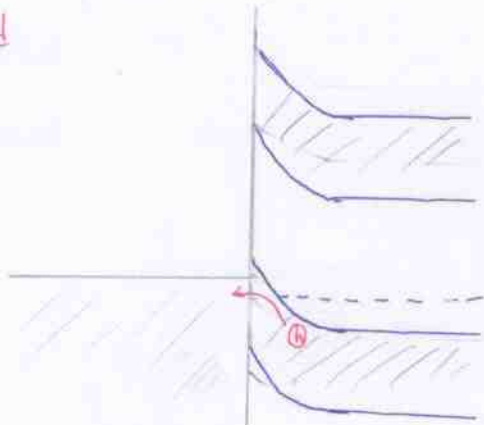
\*reverse

(-)

(+)

(+)

(-)

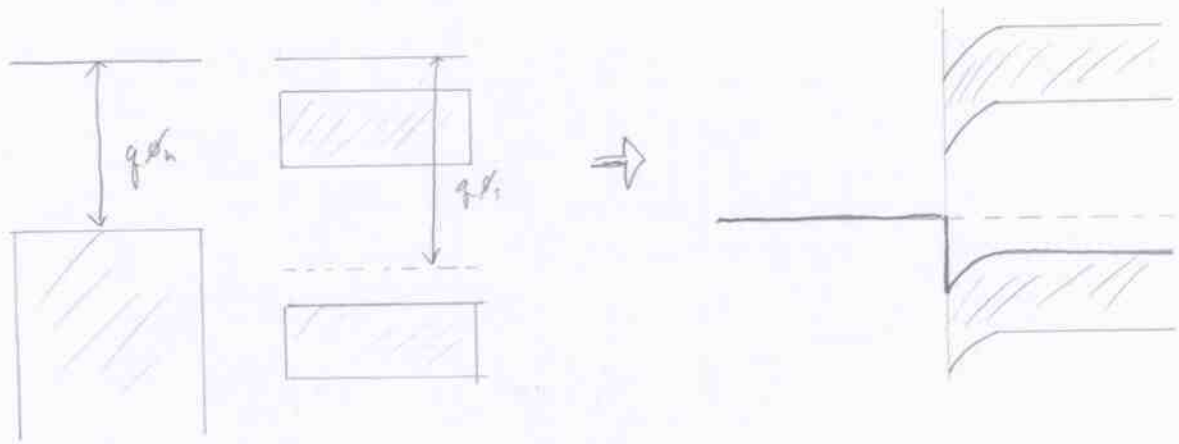


hole is major charge carrier so  
forward or reverse bias voltage is applied.

$\therefore$  ohmic contact.

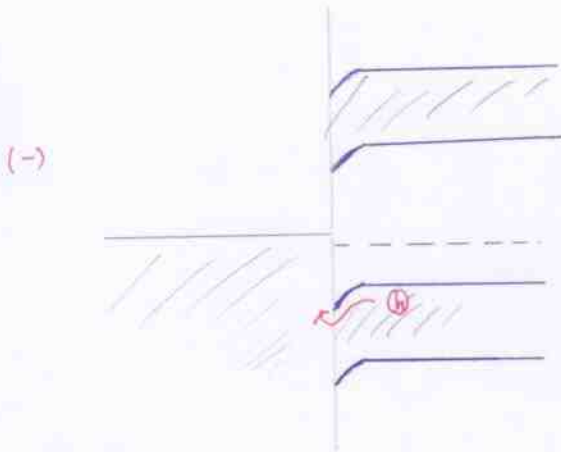


(d) P-type,  $\phi_m < \phi_s$



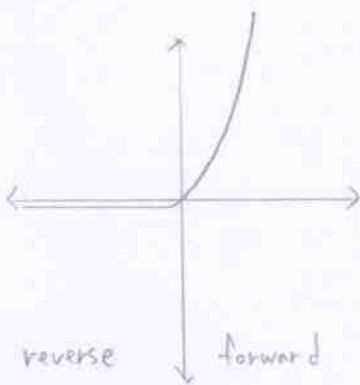
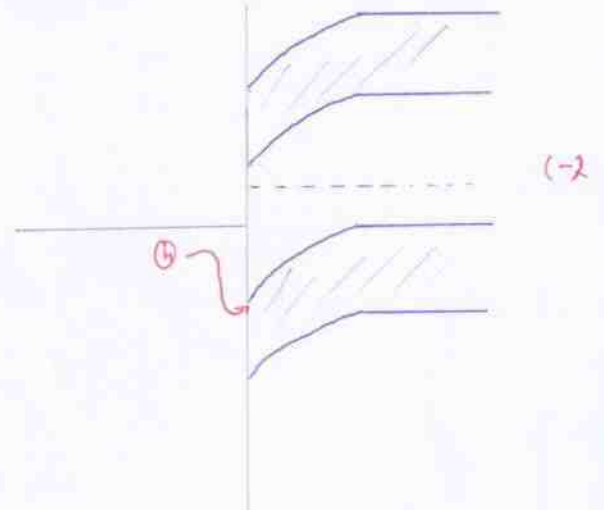
× forward

× reverse



(+)

(+)



- hole 이 major charge carrier
- forward bias 인 경우, 전압의 크기가 증가할수록 charge barrier 가 감소하고 depletion width도 감소하므로 hole의 이동이 쉬워져 큰 전류의 세기 증가.
- reverse bias 인 경우 charge barrier 가 있으므로 diffusion current가 거의 0

∴ rectifying contact.